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In re Application of:)
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 David Thomas FORREST, et al.)
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International)
Application No. PCT/US2004/040629)
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International)
Filing Date: 06 December 2004 (06.12.2004)))
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U.S. Serial No.)
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U.S. Filing Date: 05 June 2006)
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 (05.06.2006))
)
For: FREE-STANDING SILICON CARBIDE)
 ARTICLES FORMED BY CHEMICAL)
 VAPOR DEPOSITION AND METHODS)
 FOR THEIR MANUFACTURE)

Mail Stop PCT
Commissioner of Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

Attorney Docket No. 52993/326894
Date: 05 June 2006

PRELIMINARY AMENDMENT

Sir:

Kindly amend the above-identified patent application prior to examination.

Amendment to the Specification appear on page 2 of this paper.

A listing of all pending Claims begins on page 3 of this paper.

Remarks appear on page 8 of this paper.